



Docket Number: 040008-0307317

Client Reference: OG03-021

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

JAE WON HAN

Group Art Unit: 2812

Application No.: 10/747,664

Examiner: NOT ASSIGNED

Filed: December 30, 2003

Confirmation No.: 1557

For: METHOD OF FABRICATING METAL INTERCONNECTION OF
SEMICONDUCTOR DEVICE

May 26, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

PILLSBURY WINTHROP LLP

E. Rico Hernandez
Reg. No. 47641

ERH/smm
P.O. Box 10500
McLean, VA 22102
Telephone: (703) 905-2000
Facsimile: (703) 905-2500



Atty. Dkt. No.	M#	Client Ref.
	307317	OG03-021

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: HAN	
Appln. No.: 10/747,664	
Filing Date: December 30, 2003	
Examiner: NOT ASSIGNED	Group Art Unit: 2812

Date: May 26, 2004

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U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR 5,380,401	01/1995	Jones et al.			
	BR 5,661,082	08/1997	Hsu et al.			
	CR 5,814,893	09/1998	Hsu et al.			
	DR 5,920,081	07/1999	Chen et al.			
	ER 6,413,576	07/2002	Ellis et al.			
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
	MR							
	NR							
	OR							
	PR							
	QR							
	RR							
	SR							
	TR							
	UR							
	VR							

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	WR							
	XR							
	YR							
	ZR							
	AAF							
	BBF							

Examiner	Date Considered:
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.